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PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Emmanuel Hadji et al.

Serial No.: 09/673,005

Filed: November 27, 2000

Title: METHOD FOR FORMING AN OPTICAL SILICON LAYER ON A SUPPORT AND USE OF SAID METHOD IN THE PRODUCTION OF OPTICAL COMPONENTS

Docket No.: 33019

REQUEST FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The three (3) month period for response to the Office Action of September 15, 2003 in the above-identified application expired on December 15, 2003. Accordingly, applicant respectfully requests and petitions that the response date be extended for three (3) months, up to and including March 15, 2004. The \$950.00 extension of time fee is enclosed.

If there are any further fees required by this communication which are not covered by an enclosed check, please charge such fees to our Deposit Account No. 16-0820, Order No. 33019.

Respectfully submitted,

PEARNE & GORDON LLP

By:

Jeffrey J. Sopko, Reg. No. 27676

1801 East 9th Street
Suite 1200
Cleveland, Ohio 44114-3108
(216) 579-1700

Date: March 15, 2004

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Jeffrey J. Sopko

Name of Attorney for Applicant(s)

March 15, 2004

Date

Signature of Attorney